Modelling the erosion of beryllium carbide surfaces

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Abstract

Redeposition of beryllium eroded from main chamber plasma facing components of ITER onto the diverter tokamaks as well as linear plasma experiments, see, e.g., [10–15]. ERO depends crucially on high-quality data for PWI as well as for dissociation, ionization and emission data for impurities in the plasma. Molecular dynamics (MD) data improve the modelling capability of ERO by providing a more accurate description of low-energy sputtering compared to the data set [16] based on TRIM calculations.

1. Introduction

A current concern in fusion reactors is erosion of wall materials, which leads to contamination of the fusion plasma and limits the lifetime of the first wall. Low energy hydrogen isotopes escaping the fusion plasma have a strong impact on the walls of a fusion reactor. The interplay between the particles and wall materials is commonly named “plasma-wall interactions” (PWI) and will crucially contribute to the degradation of the reactor performance. PWI lead to sputtering erosion, redeposition, tritium retention, and the formation of “plasma-altered materials”, so-called mixed materials [1–3]. In this context the sputtered species will harm the plasma. The creation of a mixed material layer is noteworthy since its properties can substantially differ from those of its constituents [2].

The current wall material choice for the next generation experimental fusion reactor ITER [4] is beryllium, carbon, and tungsten [5], hence, mixed layers of these materials are expected. The rate, location and extent of the creation of mixed layers are by no means fully known, nor is the sputtering of these materials. Carbidic formation on beryllium surfaces has, however, been observed to mitigate not only the pure beryllium but also the pure carbon sputtering yields [6,7].

One of the main applications of the present work is modelling of impurity migration in fusion plasmas. For local impurity modelling the leading European code is ERO [8,9] – a 3D Monte Carlo impurity transport code that has been applied to several limiter and divertor tokamaks as well as linear plasma experiments, see, e.g., [10–15]. ERO depends crucially on high-quality data for PWI as well as for dissociation, ionization and emission data for impurities in the plasma. Molecular dynamics (MD) data improve the modelling capability of ERO by providing a more accurate description of low-energy sputtering compared to the data set [16] based on TRIM calculations.

As an attempt to gain an atomic level insight into the sputtering process of Be2C, we simulate cumulative bombardment of D on Be2C surfaces using MD. The resulting sputtering yields are applied to ITER plasma impurity modelling using ERO. Furthermore, new in this study is the investigation of the mixed material Be2C sputtering mechanism at energies up to 100 eV. Also, the materials sputtering yields at low fluences are simulated. Sputtering at higher energies (bombardment energies greater than 100 eV) is relatively well understood and hence we investigate energies near the sputtering threshold. In experiment the actual distribution of impact angles cannot be easily determined – especially in the case of rough surfaces – but it is often assumed that the angle-averaged sputtering yield is twice the yield for normal incidence. Therefore the MD simulations are limited to incidence bombardment.

2. Methods

2.1. MD simulations

MD is typically very well suited for systems containing up to several tens of millions of atoms and for timescales under 1 nanosecond. However, performing cumulative simulations, considerable parallelization is not feasible, hence, our sputtering simulations are...
limited to systems of a few thousands of atoms. This obviously does not correspond to the scale of a fusion reactor wall, but it can be considered a representative part of the wall and gives valuable insight into the microscopic phenomena plasma-wall interaction.

In this work, the simulations were performed with the PARCAS molecular dynamics code [17]. The potential describing the deuterium, beryllium, and carbon interatomic interactions, including bond breaking and forming, was recently developed by our group [18]. For our simulations, we constructed beryllium carbide antifluorite cells with the dimensions of 27.5 x 27.5 x 45.7 Å (consisting of 6 x 6 x 10 unit cells with a total of 4320 atoms). The cells were initially relaxed at 300 K using Berendsen temperature control [19]. In order to mimic the cell being a small part of the fusion reactor wall, we used the x and y directions as periodic boundaries as well as fixed the two bottommost layers of the cell in the z direction. Initial cells having either a beryllium or a carbon terminated surface were constructed.

We bombarded the initial cells cumulatively with deuterium ions where all projectiles had the same initial energy, either 10, 15, 20, 50, 75 or 100 eV. We performed up to 4000 bombardments for each energy and both C or Be terminated surfaces were used.

The impact point of the bombarding deuterium ion was randomized by shifting the cell in the x and y direction after every run while keeping the deuterium starting position at the beginning of the simulation in the middle of the xy-plane and 5 Å above the cell surface. The impact angle of the ion was normal to the surface.

Furthermore, the temperature of the border of the cell was kept at 300 K during the beginning of each bombardment and after 4 ps the whole cell was quenched to 300 K at a rate of 0.1 K/fs for 3 ps. One single bombardment simulation lasted 7 ps, thus creating a high flux of 1.88 x 10^{28} m^{-2} s^{-1} compared to the expected fluxes in ITER’s divertor being of the order of 10^{29} m^{-2} s^{-1} [5]. Our simulations reached fluxes up to 5.28 x 10^{28} m^{-2} which is much lower than typical fluxes of one 400-second-long ITER pulse, about 10^{29} m^{-2} [5].

The collisions of atoms with electrons cause the ions to slow down when entering the bulk. This damping was taken into account by adding a frictional force depending on the speed of the moving particle. The ZBL electronic stopping [20] was applied to atoms with an energy above 1 eV, not including incoming D ions or sputtered species.

We defined an atom or a molecule/cluster to be sputtered when it was no longer bonded to the surface of the cell. The sputtering yields were gained by averaging the number of eroded atoms over the number of ion impacts. The 1σ standard error of the average was calculated.

2.2. ERO simulations

Sputtering data for Be₂C cannot be directly used in the so-called homogeneous material mixing (HMM) surface model of ERO. The model is based on the assumption that all substrate and impurity materials mixing takes place in an interaction layer of user-defined thickness. The concentrations of various atom species in the interaction layer of each surface cell evolve during the simulation. At any time moment, sputtering yields, and reflection probabilities are calculated as concentration-weighted averages from the data for pure elements. We modified the surface model so that data for Be₂C – and later for other compounds/mixtures in the ITER-relevant Be/W/C system – can be added as intermediate data points for interpolation between Be and C (and W). This approach can be motivated by the experimental observation that complex binary phase diagrams for compounds with intermetallic phases frequently can be interpreted as combinations of simpler phase diagrams between the pure elements and intermetallic phases.

![Figure 1. The elemental sputtering yield for surface layers of different concentration. The point for Be₂C is obtained in this work (using the Be terminated surface data), and linear interpolations to the pure C sputtering (TRIM.SP data) and pure Be sputtering [23] are done.](image)

[21,22]. In the model we assume that the maximum stoichiometrically possible amount of Be₂C is formed. Then the data interpolation is done between Be₂C and the remaining Be or C. Fig. 1 illustrates this approach for 100 eV incoming deuterium ions.

We demonstrate the use and significance of the new data set by applying the data to the ITER tritium retention and target lifetime calculation reported in [13]. In this reference case simultaneous erosion of CFC divertor targets and beryllium deposition from the plasma has been estimated using ERO simulations. Due to the main wall erosion, it is assumed that the deuterium plasma flowing onto the divertor targets contains 0.1% beryllium. To separate the effects of new data for beryllium self sputtering (from Ref. [18]) and the description for Be₂C formation, we applied them both separately and together to the reference case. Only using the pure beryllium data is denoted “case 1” and the Be₂C model is “case 2”.

3. Results and discussion

3.1. MD sputtering yields

Table 1 shows the total number of sputtered atoms as well as every type of molecules that were sputtered in the D on Be₂C simulations. As seen, there was a significant amount of both sputtered Be and C atoms at energies near to 100 eV. The BeD sputtering is noteworthy, and these molecules have been observed in D plasma sputtering experiment in the PISCES-B facility in San Diego [24,7] and in earlier simulations of pure Be samples [23]. Other interesting molecules which we found to be sputtered are BeD₂ and CD₂. Overall, very few hydrocarbons and only one methane molecule CD₄ were observed. As expected, the carbon terminated surface has a larger sputtering yield of carbon than the beryllium terminated surface.

Fig. 2 shows the sputtering yield for the Be-terminated surface and the C-terminated surface. For comparison experimental data is added. The Exp. data 1 in Fig. 2 are ion beam experimental results published in [25] and the Exp. data 2 [7] are from the linear plasma device PISCES-B. In the latter, the sputtering yields were measured for in situ plasma-deposited Be layers on C. When these elements come in contact, Be₂C can form. The sputtering data were gathered after the topmost layer consisting of Be had been removed probably leaving behind a Be₂C layer. The sputtering yields of the two experiments (where different samples and different methods have...
3.2. ERO modelling: MD sputtering yields implementations

For the plasma impurity modelling, the MD simulation data were fitted with the Bohdansky formula [28]

\[
Y(E_0, \alpha = 0^\circ) = Q_s^{SC}(\varepsilon) \left( 1 - \frac{E_{th}}{E_0} \right)^{2/3} \left( 1 - \frac{E_{th}}{E_0} \right)^2
\]

(1)

for calculating sputtering yields from test particle impacts (with normal incidence) in the ERO code. Here \( Q \) and \( E_{th} \) (threshold energy where the sputtering yield becomes zero) are fitting parameters that were imported to ERO, \( \varepsilon = E_0/E_{TF} \), where \( E_{TF} \) is the Thomas–Fermi energy, and \( Q_s^{SC} \) is the nuclear stopping cross section based on the Kr-C potential, given by [8]

\[
Q_s^{SC}(\varepsilon) = \frac{0.5 \ln(1 + 1.2288\varepsilon)}{\varepsilon + 0.1728\varepsilon^2 + 0.008\varepsilon^{1.504}}
\]

(2)

In addition to Be sputtering by D and Be, we also expressed the Be₂C sputtering using this formula. The resulting values for fitting parameters \( Q \) and \( E_{th} \) are given in Table 2. For background plasma sputtering, the yields were averaged over the Maxwellian energy distribution and an assumed cosine distribution for the impact angle. Ions are accelerated towards the surface in the plasma sheath; therefore the averaged yields are expressed as functions of the electron temperature separately for each charge state (see Figs. 3 and 4).

### 3.3. The sputtering mechanism, D on Be₂C

The main sputtering mechanisms have been identified as physical sputtering and swift chemical sputtering (SCS) [29–31,23,32]. Previous MD simulations with deuterium bombardment on pure beryllium surfaces have also identified these to be the main sputtering mechanisms [23]. Figs. 5 and 6 show the ratio of beryllium and carbon sputtered as molecules. The fraction illustrates the significance of either the physical or the SCS process, as single atoms are mostly sputtered by the physical sputtering mechanism and molecules/clusters are mostly sputtered by the SCS mechanism. In the low energy range (15–20 eV) SCS occurred more frequently while for the higher energy ranges (75–100 eV) physical sputtering occurred more frequently.

Fig. 7 shows a single case for SCS on the carbon terminated surface for a Be atom at 15 eV deuterium bombardment. The pictures (a)–(f) are snapshots from the sputtering process at the indicated times in the energy graph, which illustrates the kinetic energy of the incoming D ion and the change in potential energy of the atom times in the energy graph, which illustrates the kinetic energy of the incoming D ion and the change in potential energy of the atom.

### Table 1
Sputtered molecules during deuterium bombardment of beryllium carbide (Be₂C).

<table>
<thead>
<tr>
<th>D energy (eV)</th>
<th>Be</th>
<th>BeD</th>
<th>Be₂D</th>
<th>Be₃D</th>
<th>BeC</th>
<th>C₂</th>
<th>CD</th>
<th>CD₂</th>
<th>CD₄</th>
<th>Tot. sput.</th>
<th>No. bomb.</th>
</tr>
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<tbody>
<tr>
<td>Be-surf.</td>
<td>10</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>3200</td>
</tr>
<tr>
<td>15</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>1</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>4000</td>
</tr>
<tr>
<td>20</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>1</td>
<td>0</td>
<td>0</td>
<td>1</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>8</td>
</tr>
<tr>
<td>50</td>
<td>11</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>1</td>
<td>1</td>
<td>0</td>
<td>0</td>
<td>30</td>
</tr>
<tr>
<td>75</td>
<td>15</td>
<td>0</td>
<td>0</td>
<td>1</td>
<td>0</td>
<td>0</td>
<td>1</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>33</td>
</tr>
<tr>
<td>100</td>
<td>34</td>
<td>0</td>
<td>0</td>
<td>1</td>
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<td>0</td>
<td>1</td>
<td>0</td>
<td>0</td>
<td>0</td>
<td>54</td>
</tr>
</tbody>
</table>

| C-surf.     | 10 | 0   | 0    | 0    | 0   | 0  | 0  | 0    | 0    | 0          | 4000      |
| 15          | 0  | 0   | 0    | 0    | 0   | 0  | 1  | 0    | 0    | 0          | 2400      |
| 20          | 1  | 0   | 0    | 0    | 0   | 0  | 1  | 0    | 0    | 0          | 3200      |
| 50          | 6  | 0   | 0    | 0    | 0   | 0  | 1  | 0    | 0    | 0          | 4000      |
| 75          | 15 | 0   | 0    | 0    | 0   | 0  | 1  | 0    | 0    | 0          | 27        |
| 100         | 22 | 0   | 0    | 0    | 0   | 0  | 1  | 0    | 0    | 0          | 40        |

* In fact, a BeDCD molecule sputtered.
** In fact, a BeDCD₃ molecule sputtered.

![Table 2](M. Mehine et al. / Journal of Nuclear Materials 414 (2011) 1–7)

### Table 2
Fitting parameters for the Bohdansky formula, Eq. (1).

<table>
<thead>
<tr>
<th>Old</th>
<th>New</th>
</tr>
</thead>
<tbody>
<tr>
<td>Q</td>
<td>E_{th}</td>
</tr>
<tr>
<td>D on Be</td>
<td>0.11</td>
</tr>
<tr>
<td>Be on Be</td>
<td>0.67</td>
</tr>
<tr>
<td>D on Be₂C</td>
<td>0.0526</td>
</tr>
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</table>
energy of the D ion drops three times indicating collisions with substrate atoms and at each kinetic energy loss there is a corresponding potential energy gain. As the bombarding deuterium ion loses almost all of its kinetic energy it binds with a nearby atom, which is seen in the graph as a flattening of the kinetic energy curve. Meanwhile, bonds to the surface are broken and a Be and one of its D neighbours escape as a sputtered BeD molecule.

As mentioned above, SCS occurred mostly at the lower energies (15–20 eV), probably due to the high deuterium contamination within the near-surface layers of the material. This changed the surface structure from the antifluorite structure to a mixture of D, Be, and C with a large deuterium concentration. Similar surface composition change occurred for the pure beryllium case[23]. This means that the surface Be atoms have many bonds to D atoms and fewer bonds to other Be or C atoms, thus requiring much less energy to be released from the surface than would be the case for a perfect surface.

For the higher energy bombardment cases, where mostly physical sputtering occurred, a transformation from an ordered antifluorite structure to an amorphous Be–C–D mixture also took place, but due to the lower deuterium concentration at the surface the chemical sputtering mechanism was not as effective as in the lower energy cases. Also, a higher velocity of an incoming ion makes bond-breaking less probable due to ineffective momentum transfer[30].

Fig. 8 shows the ratio of sputtered carbon atoms versus sputtered beryllium atoms for the carbon terminated surfaces. It is evident that more Be than C atoms sputter even though most sputtered Be or C originated from the topmost surface which was originally made of carbon. Especially for the higher energies beryllium sputters more easily than carbon because of its lower mass.

At lower energies (15–20 eV) the ratio of sputtered C atoms to Be atoms is also low probably because that there were twice as many Be than C atoms in the sample and consequently also in the surface layers. The peak in the carbon sputtering yield at 15 eV is due to one CD₃ and one CD₄ molecule that were sputtered early (during the first 800 bombardments) when the surface still consisted mainly of carbon. Nevertheless, these events show that D ions of only 15 eV are capable of eroding both Be and C.

Interestingly, there was no sputtering at 15 eV for the beryllium terminated surface as opposed to the carbon terminated surface where both beryllium and carbon atoms were sputtered. This indicates that 15 eV is very close to the sputtering threshold. Furthermore, no sputtering occurred for any surfaces at 10 eV indicating that the threshold lies between 10 and 15 eV.

The sputtered atoms were loosely bound surface atoms, which easily break loose by the SCS mechanism. This is seen in Fig. 9 which illustrates the number and type of initial neighbours of

![Graph](image-url)
the sputtered atoms. At low bombarding energies, 15 and 20 eV, the sputtered atoms have many deuterium neighbours and are more probable to be sputtered.

3.4. Blistering

In the 75 eV beryllium terminated surface simulation, a bubble of deuterium was formed inside the cell. Eventually, the bubble grew large enough to separate the topmost layer from the rest of the cell causing one fourth of the cell to be sputtered. This did only occur for 1 of the 12 simulations, however, it significantly increased the sputtering yield from 0.008 to approximately 0.25 and as such is worth to further investigate. This might be an artefact of the high deuterium flux that was used and/or due to not allowing for thermal migration because of the short time scale in the simulations. Similar blistering/flaking effects have also been observed in WC [33].

3.5. ERO results

Fig. 10 shows how the beryllium content of the simulated target area evolves in time in the different ERO simulation cases. A general observation is that the new (pure Be) data set, case 1, decreases accumulation of Be (by increasing sputtering) whereas the new Be2C model, case 2, has an opposite effect. Applied simultaneously, the Be2C model to some extent overrides the effect of the new data. Fig. 11 shows the surface concentration profile of Be along the outer target after 15 s of plasma exposure in different
ERO simulation cases. In case 1, the importance of MD data for outer strike point erosion is evidenced by a notable reduction in beryllium accumulation around the strike point.

MD simulations predict generally lower sputtering than the TRIM data used in ERO. For Be on Be, the MD data are systematically lower than TRIM data. Also the new Be$_2$C model suppresses sputtering of both Be and C in comparison to the HMM model. However, Be sputtering by D from pure Be in the low-energy range ($T_e < 8$ eV for the energy-angle-averaged data) is enhanced as shown in Fig. 3. Because of the target plasma conditions and strong peaking of the particle flux at the outer strike point, this effect is the dominant one in ITER divertor. The electron temperature at the target is about 1 eV in the private-flux region and about 15 eV in the far scrape-off-layer, with a rather steep gradient over a distance about 10 cm, see Fig. 1 of [13].

4. Conclusions

This work describes the sputtering of beryllium carbide Be$_2$C by identifying the underlying sputtering mechanisms to be both physical and swift chemical sputtering. It is shown that molecules such as BeD, BeD$_2$, and hydrocarbons are sputtered. Furthermore, the results agree quantitatively with the existing, although very scattered, experimental data. More exhaustive experimental confirmation is, however, needed for thorough comparisons.

The threshold for sputtering was determined to lie between 10 and 15 eV. This is a lower thresholds predicted by only considering physical sputtering and implies shorter fusion reactor lifetimes. Both beryllium and carbon atoms are sputtered, though beryllium is seen to sputter preferentially. With ITER in mind, more beryllium than carbon sputtering increases the efficiency as less heat is needed to compensate for the impurity plasma cooling effect.

A high flux of deuterium, like the ones used in the simulations, $1.88 \times 10^{28}$ m$^{-2}$ s$^{-1}$, may lead to deuterium bubble formation and bursting, causing significant sputtering. This might be due to the short simulation time not allowing migration.

This work is a step further in a theoretical understanding of the erosion of mixed materials formed in ITER. It adds to the plasma impurity code ERO an improved surface model that can be later augmented with data for other compounds/mixtures in the Be/C/W system. The sputtering yields obtained in MD simulations were used in plasma impurity simulations for the outer divertor of ITER. With new data for pure Be sputtering and/or with the new Be$_2$C model the accumulation rate of impurity beryllium from plasma to the divertor target changes within a ±25% range compared to the estimate given in [13]. Such changes are modest in the view that the tritium retention rate based on this estimate increased by about 50% in the update given in [34]. Extension of the data set to the full ITER material mix will be reported in a subsequent paper.
Acknowledgments

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References

[17] K. Nordlund, transcarb project. The main principles of the molecular dynamics algorithms are presented in [35,36]. The adaptive time step and electronic stopping algorithms are the same as in [37,2006].